

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Toshihiro KURIYAMA : Confirmation Number:
Serial No.: : Group Art Unit:
Filed: April 15, 2004 : Examiner:
For: SOLID-STATE IMAGING DEVICE AND METHOD FOR PRODUCING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the document listed on the attached form PTO-1449. It is respectfully requested that the document be expressly considered during the prosecution of this application, and that the document be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of Japanese Patent Laid-Open Publication No. 2000-164837, is discussed in the present specification.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.C./

Serial No.:

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Respectfully submitted,

MCDERMOTT, WILL & EMERY


Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:gav
Facsimile: (202) 756-8087
Date: April 15, 2004

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| INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449) | | | ATTY. DOCKET NO. 69804-016 | SERIAL NO. |
|---|----------|---|--|--|
| | | | APPLICANT Toshihiro KURIYAMA | |
| | | | FILING DATE April 15, 2004 | GROUP |
| U.S. PATENT DOCUMENTS | | | | |
| EXAMINER'S INITIALS | CITE NO. | Document Number Number-Kind Code(s if known) | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document |
| | | US | | |
| FOREIGN PATENT DOCUMENTS | | | | |
| EXAMINER'S INITIALS | CITE NO. | Foreign Patent Document Country Codes-Number +-Kind Codes(if known) | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document |
| | | JP 2000-164837 | 06/16/2000 | SONY CORP. |
| | | | | Pages, Columns, Lines Where Relevant Figures Appear |
| | | | | Yes |
| | | | | No |
| | | | | JAPAN (w/English Abstract) |
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| OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | |
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| EXAMINER /Chia Wei Chen/ | | | DATE CONSIDERED 04/29/2008 | |

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Include copy of this form with next communication to applicant.

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